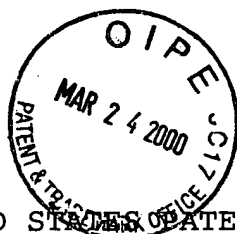


35.C13974



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
TADAHIRO OHMI, ET AL.)	Examiner: Not Yet Assigned
Application No.: 09/425,015)	Group Art Unit: 2874
Filed: October 25, 1999)	
For: GAS SUPPLY PATH)	
STRUCTURE, GAS SUPPLY)	
METHOD, LASER OSCILLATING))	
APPARATUS, EXPOSURE)	
APPARATUS, AND DEVICE)	
PRODUCTION METHOD)	March 23, 2000

5/I.D.S
G. Stanley
3-29-00

Assistant Commissioner for Patents
Washington, D.C. 20231

SECOND INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

Applicants also cite two U.S. Patents which were cited in a Search Report dated February 11, 2000. A copy of the Report is enclosed for the Examiner's convenience.

CERTIFICATION UNDER 37 C.F.R. § 1.97(e)

It is hereby certified that the two U.S. patents cited in this information disclosure statement were cited in

a communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

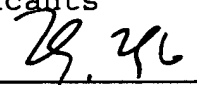
Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants

Registration No.



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